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	Filing Date		2004-01-20	
	First Named Inventor Ron		Ronald J. Berenson	
	Art Unit		1651	
	Examiner Name	Taeyo	oon Kim	
	Attorney Docket Numb	er	980034.417C5	

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/TK/	JACKSON et al., Small-Scale Monoclonal Antibody Production In Vitro: Methods And Resources, Proceedings of the Production of Monoclonal Antibodies Workshop, August 29, 1999, Bologna, Italy, http://altweb.jhsph.edu/topics/mabs/ardf/jackson.htm, accessed April 17, 2007.						
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